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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

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**APPLICANTS: Lee Shuit-Tong; Beilo Igor; Lee Chun-Sing; Li Quan; Shang Naigui;					
**CONTINUING DATA VERIFIED: SHV none					
** FOREIGN APPLICATIONS VERIFIED: SHV none					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no Verified and Acknowledged Examiner's initials SHV				ATTORNEY DOCKET NO 12364.36US01	
TITLE : Large area silicon cone arrays fabrication and cone based nanostructure modification					

U.S. DEPT. OF COMM./PAT. & TM-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE Application Examiner	
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